

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. .... 10/622,295  
Filing Date ..... July 17, 2003  
Inventor ..... Joel A. Drewes  
Assignee ..... Micron Technology, Inc.  
**Priority** Group Art Unit ..... 2824  
**Priority** Examiner ..... Bradley Smith  
Attorney Docket No. .... MI22-2342  
Title: Semiconductor Constructions and Methods of Forming Semiconductor  
Constructions

Commissioner for Patents  
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Dated: September 2, 2003

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Inventor: Joel A. Drewes

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Assignee: Micron Technology, Inc.

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**INFORMATION DISCLOSURE STATEMENT**

**PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98**

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a divisional application of co-pending application Serial No. 10/121,298, filed April 11, 2002. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. 37 C.F.R. § 1.98(d) and MPEP § 609(2).

Citation of these references is respectfully requested.

Respectfully submitted,

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Dated: 9/2/03

By: 

David G. Latwesen, Ph.D.  
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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-2342	SERIAL NO. 10/622,295	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Joel A. Drewes		
				FILING DATE July 17, 2003	GROUP Unknown	
U.S. PATENT DOCUMENTS						
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
AA	6,577,529 B1	06-2003	Sharma et al.			
AB						
AC	US2002/0105035A1	06-2002	Sandhu et al.			
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AJ						
AK						
AL						
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	Document Number	Date	Country	Class	Subclass	Translation
						Yes No
AM						
AN						
AO						
AP						
AQ						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)						
AR		WEBSITE: <a href="http://digitalander.iol.it/patent/what_mu_metal.htm">http://digitalander.iol.it/patent/what_mu_metal.htm</a> , "What's $\mu$ -metal?", printed 2/26/2002, 2 pages.				
AS		WEBSITE: <a href="http://www.science.net.org.uk/database/Physics/0812/p01213d.html">http://www.science.net.org.uk/database/Physics/0812/p01213d.html</a> , "Physics & Astronomy: What's mu metal?", printed 2/26/2002, 1 pg.				
AT						
EXAMINER			DATE CONSIDERED			
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>						